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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 23, 2006

(Date of Deposit)

Harold C. Moore

Name of person mailing Document or Fee

Signature

January 23, 2006

Date of Signature

Re: Application of: Hans Taddiken  
Serial No.: 10/826,921  
Filed: April 16, 2004  
For: Semiconductor Structure Having a  
Compensated Resistance in the LDD Area  
and Method for Producing the Same  
Group Art Unit: 2815  
Examiner: Jose R. Diaz  
Our Docket No.: 1890-0079

# TRANSMITTAL

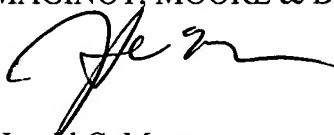
Please find for filing in connection with the above patent application the following:

1. Response to Restriction Requirement; and
2. One (1) return post card.

Please charge any fee deficiency, or credit any overpayment, to Deposit Account No. 13-0014; but not to include any payment of issue fees.

Respectfully Submitted,

MAGINOT, MOORE & BECK

A handwritten signature in black ink, appearing to read 'H. C. Moore', written over the firm name.

January 23, 2006

Harold C. Moore  
Registration No. 37,892  
Chase Tower  
111 Monument Circle, Suite 3250  
Indianapolis, Indiana 46204-5115

Enclosures



THE UNITED STATES PATENT AND TRADEMARK OFFICE

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**RESPONSE TO RESTRICTION REQUIREMENT**

Sir:

In response to the Office Action dated December 23, 2005 for the above-identified patent application, please consider the following election.